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SUPPLEMENTAL FORM PTO-1449 TO BE FILED WITH INFORMATION DISCLOSURE STATEMENT

| INFORMA S. Department of Commerce tent and Trademark Office | | Atty. Docket No. <u>OSU1159-141</u> Serial No. <u>09/755,43</u> | | |
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| | | Richard L. McCreery | | |
| FORMATION SCLOSURE STATEMENT | | Applicant | | OCI 10 |
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| | • | | Examiner' | s name |
| | U | S. PATENT DOCU | JMENTS | |
| Examiner's | Document | Date | Name | Class/Sub- |
| Initial | Number | | | class |
| REE | 4,828,917 | 05/09/1989 | Wegner et al. | 428/333 |
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| | FOR | EIGN PATENT DO | OCUMENTS | |
| Examiner's | Document | Date | Country/Name | Translation |
| | Number | + | , | yes/no |
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| U.S. Department of Commerce Patent and Trademark Office | Atty. Docket No. OSU11 | 59-141 Serial No. <u>09/755,437</u> |
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| | Richard L. McCre | ery |
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